

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Patent Application of:

Samu NAKAMURA et al.

Serial No. 10/056,055

Filed: January 28, 2002

For: SEMICONDUCTOR DEVICE AND

MANUFACTURING METHOD OF

THE SAME

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) Art Unit: 2811

) Examiner: Unknown

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents and Trademarks
Washington, D.C. 20231

Sir:

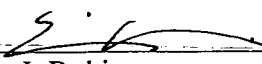
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application. Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Examiner's attention is particularly directed to JP 05-109737, which discloses a gettering by using argon gas.

The documents are being submitted within 3 months of the filing, or entry into the national phase, of this application or before the first Office Action on the merits, whichever is later, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 19-2380 (740756-2428).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

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Form PTO-1449
(Rev. 8-83)

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U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0756-2428

Serial No. 10/056,055

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Applicants: Osamu NAKAMURA et al.

Filing Date: January 28, 2002

Group Art Unit: 2811

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
	5,529,937	06/25/1996	Zhang et al.			
	5,608,232	03/04/1997	Yamazaki et al.			
	5,639,698	06/17/1997	Yamazaki et al.			
	5,700,333	12/23/1997	Yamazaki et al.			
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	5,814,540	09/29/1998	Takemura et al.			
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	5,893,730	04/13/1999	Yamazaki et al.			
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*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	6,316,789	11/13/2001	Yamazaki et al.			
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Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
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